

Message Text

CONFIDENTIAL

PAGE 01 STATE 301456

12
ORIGIN EB-07

INFO OCT-01 CIAE-00 COME-00 DODE-00 NRC-05 NSAE-00 TRSE-00

EUR-12 ERDA-05 ISO-00 EA-07 ACDA-05 /042 R

DRAFTED BY EB/ITP/EWT:RWPRACHT:ERS

APPROVED BY EB/ITP/EWT:RWPRACHT

RPE

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R 231802Z DEC 75

FM SECSTATE WASHDC

TO USMISSION OECD PARIS

C O N F I D E N T I A L STATE 301456

EXCON

E.O. 11652: XGDS-1

TAGS: ESTC, COCOM

SUBJECT: COCOM LIST REVIEW: IL 1355, SEMICONDUCTOR
MANUFACTURING EQUIPMENT

REF: OECD PARIS 33410

WE HAVE NO ONE SUFFICIENTLY PROFICIENT IN FRENCH WHO
WAS AT DISCUSSIONS TO CLEAR THE DRAFT RECORD OF
DISCUSSION. IF POSSIBLE, WE WOULD PREFER TO HAVE
ENGLISH VERSION TO CLEAR. PLEASE ADVISE WHETHER THIS
IS POSSIBLE. NOTE, THERE IS NO URGENCY FOR FINAL
RECORD ON THIS ITEM. KISSINGER

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NNN

Message Attributes

Automatic Decaptoning: X
Capture Date: 01 JAN 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: STRATEGIC TRADE CONTROLS, EXCEPTIONS LIST, SEMICONDUCTOR DEVICES
Control Number: n/a
Copy: SINGLE
Draft Date: 23 DEC 1975
Decaption Date: 01 JAN 1960
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Authority: GarlanWA
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 28 MAY 2004
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1975STATE301456
Document Source: CORE
Document Unique ID: 00
Drafter: RWPRACHT:ERS
Enclosure: n/a
Executive Order: X1
Errors: N/A
Film Number: D750446-0523
From: STATE
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1975/newtext/t19751218/aaaaapple.tel
Line Count: 47
Locator: TEXT ON-LINE, ON MICROFILM
Office: ORIGIN EB
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 1
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: 76 OECD PARIS 33410
Review Action: RELEASED, APPROVED
Review Authority: GarlanWA
Review Comment: n/a
Review Content Flags:
Review Date: 20 MAY 2003
Review Event:
Review Exemptions: n/a
Review History: RELEASED <20 May 2003 by GarlanWA>; APPROVED <29 MAY 2003 by GarlanWA>
Review Markings:

Margaret P. Grafeld
Declassified/Released
US Department of State
EO Systematic Review
06 JUL 2006

Review Media Identifier:
Review Referrals: n/a
Review Release Date: N/A
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
Secure: OPEN
Status: NATIVE
Subject: COCOM LIST REVIEW: IL 1355, SEMICONDUCTOR MANUFACTURING EQUIPMENT
TAGS: ESTC, COCOM
To: OECD PARIS
Type: TE
Markings: Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 06 JUL 2006